

10/540992

JC17 Rec'd PCT/PTO 28 JUN 2005

Attorney Docket No. 061063-0316598
Client Reference: OSP-18418

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: JEA GUN PARK, UN GYU PAIK, JIN HYUNG PARK, and TAKEO KATO

Application No.:

Confirmation

No:

Filed: June 28, 2005

Group No.:

Examiner

For: CHEMICAL-MECHANICAL-POLISHING SLURRY COMPOSITION, METHOD FOR PLANARIZING SURFACE OF SEMICONDUCTOR DEVICE USING THE SAME, AND METHOD FOR CONTROLLING SELECTION RATIO OF SLURRY COMPOSITION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

APPLICATION DATA SHEET
37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: JEA GUN PARK
Citizenship: REPUBLIC OF KOREA
Residence: Seongnam-city, Kyungki-do, Republic of Korea

Second applicant: UN GYU PAIK
Citizenship: REPUBLIC OF KOREA
Residence: Kangnam-gu, Seoul, Republic of Korea

Third applicant: JIN HYUNG PARK
Citizenship: REPUBLIC OF KOREA
Residence: Ulsan-city, Republic of Korea

Fourth applicant: TAKEO KATO
Citizenship: JAPAN
Residence: Seongdong-gu, Seoul, Republic of Korea

2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

3. Application information

Title of Invention: CHEMICAL-MECHANICAL-POLISHING SLURRY COMPOSITION,
METHOD FOR PLANARIZING SURFACE OF SEMICONDUCTOR DEVICE USING THE
SAME, AND METHOD FOR CONTROLLING SELECTION RATIO OF SLURRY
COMPOSITION

Docket number assigned to this application: 061063-0316598

Suggested Classification: Class:
Subclass:

Technology Center to which subject matter is assigned:

Total number of drawing sheets: 10

Type of application: Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

5. Domestic Priority information

Domestic priority for this application is claimed as follows:

35 U.S.C. § 365(c):

Application No.: PCT/JP03/16813

Filed: December 25, 2003

Status: Pending

Relationship: Parent

6. Foreign priority information

Foreign priority is claimed for this application as follows:

Country: REPUBLIC OF KOREA

Application No.: 10-2002-0087934

Filing Date: December 31, 2002

Status: Pending

7. Assignee information

The assignee(s) of this application is/are:

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JAPAN

Extent of interest of assignee in application: undivided interest

10/540992

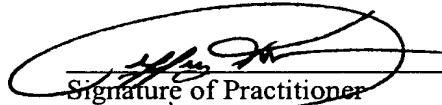
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Extent of interest of assignee in application: undivided interest

Date: June 28, 2005

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